

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Tatsuo ITO et al.

Application No.: New U.S. National Stage of PCT/JP03/00557

Filed: July 26, 2004

Docket No.: 120503

For: METHOD FOR MANUFACTURING SEMICONDUCTOR WAFER, METHOD FOR  
RECEIVING ORDER FOR MANUFACTURE OF SEMICONDUCTOR WAFER, AND  
SYSTEM FOR RECEIVING ORDER FOR MANUFACTURE OF SEMICONDUCTOR  
WAFER

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. Relevance of non-English language reference No. 4 is discussed in the present specification.
- ☒ 3. Reference Nos. 1-3 were cited in a counterpart foreign application. An English language version of the foreign search report is attached for the Examiner's information.
- ☒ 4. English-language Abstracts of non-English language reference Nos. 1-4 are attached hereto.

10/502389

New U.S. National Office of PCT/JP03/00557

DT12 REC'D PCT/PTO 26 JUL 2004



5. A computer-generated English translation of the following Japanese Patent Publication has been obtained from the website of the Japanese Patent Office ([<http://www.jpo.go.jp>]), and is attached, but has not been reviewed for accuracy. See References 1 and 2.

Respectfully submitted,



William P. Berridge  
Registration No. 30,024

Thomas J. Pardini  
Registration No. 30,411

WPB:TJP/mxm

Date: July 26, 2004

**OLIFF & BERRIDGE, PLC**  
**P.O. Box 19928**  
**Alexandria, Virginia 22320**  
**Telephone: (703) 836-6400**

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Sheet 1 of 1

Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 120503		APPLICATION NO. New U.S. National Stage of PCT/JP03/00557	
INFORMATION DISCLOSURE STATEMENT  (Use several sheets if necessary)				APPLICANTS Tatsuo ITO et al.			
				FILING DATE July 26, 2004			

  

U.S. PATENT DOCUMENTS						
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS

  

FOREIGN PATENT DOCUMENTS						
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS
	1	JP A 2002-24634 w/ Abst & Trans	1/25/2002	Japan		
	2	JP A 11-245750 w/ Abst & Trans	12/14/1999	Japan		
	3	JP A 4-73925 w/ Abstract	3/9/1992	Japan		
	4	WO 02/41380 A1 w/ Abstract	5/23/2002	Japan		

  

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)		

  

EXAMINER	DATE CONSIDERED
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

Date: July 26, 2004